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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q56532

Hideya TAKEO

Appln. No.: 09/489,846

Group Art Unit: 2621

Confirmation No.: 6337

Examiner: Patrick L. EDWARDS

Filed: January 24, 2000

For: ABNORMAL PATTERN DETECTION PROCESSING METHOD AND SYSTEM

**SUPPLEMENTAL AMENDMENT**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 21, 2005 and Advisory Action dated June 30, 2006, please amend the above-identified application as follows on the accompanying pages.

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